

Electronic Patent Application Fee Transmittal

Application Number:	10798331			
Filing Date:	12-Mar-2004			
Title of Invention:	Method for manufacturing sputter-coated substrates, magnetron source and sputtering chamber with such source			
First Named Inventor/Applicant Name:	Stanislav Kadlec			
Filer:	Ronald J. Shore/Krista Hargrove			
Attorney Docket Number:	635.43483X00			
Filed as Large Entity				
Utility under 35 USC 111(a) Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 3 months with \$0 paid	1253	1	1110	1110

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Total in USD (\$)				1110